



**ELECTRONIC COPY**

LG792636770  
Report verification at igi.org



April 16, 2026

IGI Report Number **LG792636770**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.53 - 6.57 X 4.10 MM**

**GRADING RESULTS**

Carat Weight **1.10 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

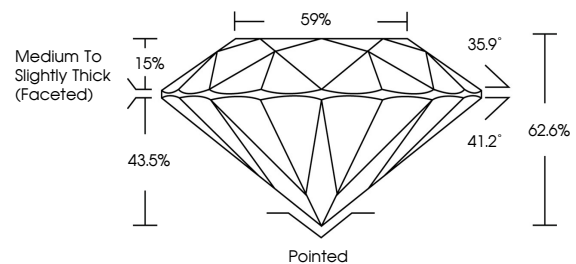
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG792636770**

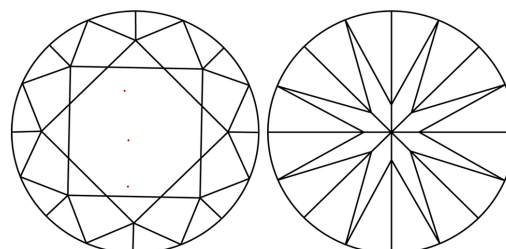
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

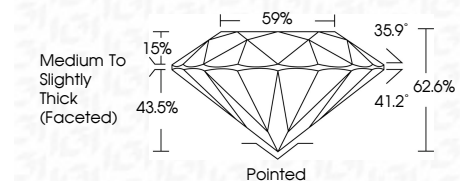
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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**IGI**



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**ROUND BRILLIANT**  
6.53 - 6.57 X 4.10 MM  
1.10 CARAT  
E  
Color Grade  
VVS 2  
Clarity Grade  
EXCELLENT  
Depth  
62.6%  
59%  
Medium To Slightly Thick (Faceted)  
Culet  
Pointed  
Polish  
EXCELLENT  
Symmetry  
EXCELLENT  
Fluorescence  
NONE  
Inscription(s)  
IGI LG792636770  
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